

JPM



Docket No.: 8733.330.10-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Byung-Chul Ahn

Application No.: 10/612,945

Filed: July 7, 2003

For: POLYSILICON THIN FILM TRANSISTOR
USED IN A LIQUID CRYSTAL DISPLAY
AND THE FABRICATING METHOD

Confirmation No.: 6662

Art Unit: 2811

Examiner: S. H. Yin

Customer No.: 30827

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated April 30, 2004 (Paper No. 20040428), please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Amendments to the Abstract begin on page 5 of this paper.

Remarks begin on page 6 of this paper.